

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yuichiro Sasaki, et al.
Application No. : 10/599,205
Filed : September 22, 2006
Title : METHOD OF IMPURITY INTRODUCTION, IMPURITY INTRODUCTION APPARATUS AND SEMICONDUCTOR DEVICE PRODUCED WITH USE OF THE METHOD

Conf. No. : 5783
Art Unit : 2893
Examiner : Monica D. Harrison

Customer No. : 52054
Docket No. : NGB-41341

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT "C"

Sir:

This amendment is filed in response to the Office action dated July 24, 2008. The three-month period for responding to the Office action expires on October 24, 2008.

Please amend the above-identified application in the following manner.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.